IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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5298-08101 Atty. Dkt. No.

PM01039D

Inventor(s):

Krishnaswamy Ramkumar

Frederick B. Jenne

Title:

SONOS STRUCTURE INCLUDING A

DEUTERATED OXIDE-SILICON INTERFACE AND METHOD FOR

MAKING THE SAME

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VA 22313.

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Dear Sir:

The captioned application is a divisional application from prior application 10/094,108 filed May 8, 2002 pursuant to 37 C.F.R. § 1.53(b). Prior to initial examination of the captioned matter, please amend the case as follows:

Amendments to the Title begin on page 2 of this paper.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 5 of this paper.

Amendments to the Title

Please replace the title on the cover page of the specification with the following rewritten title.

SONOS STRUCTURE INCLUDING A DUETERATED <u>DEUTERATED</u> OXIDE-SILICON INTERFACE AND METHOD FOR MAKING THE SAME